

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE CENEY CEN

In re Application of:

Syed Sajid Ahmad

Serial No.: 09/943,967

Filed: August 30, 2001

For: APPARATUS AND METHOD FOR CONTROLLING THE DEPTH OF IMMERSION OF A SEMICONDUCTOR ELEMENT IN AN EXPOSED SURFACE OF

VISCOUS FLUID

Confirmation No.: 2663

Examiner: M. Trinh

**Group Art Unit: 2822** 

Attorney Docket No.: 2269-3428.2US

(97-0828.02/US)

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria; VA 22313-1450.

January 30, 2004

Date

Leah J. Barrow

Name (Type/Print)

## **AMENDMENT**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The following amendments and remarks are filed in response to the Examiner's remarks in the Office Action mailed November 10, 2003, the three-month shortened statutory period for response to which expires on February 10, 2004.

Amendments to the Title appear on page 2 of this paper.

Amendments to the Specification begin on page 3 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 5 of this paper.

Remarks/Arguments begin on page 21 of this paper.

## IN THE TITLE:

The title has been amended herein. Pursuant to 37 C.F.R. §§ 1.121 and 1.125 (as amended to date), please enter the title as amended.

APPARATUS AND METHOD FOR CONTROLLING THE DEPTH OF IMMERSION OF A SEMICONDUCTOR ELEMENT IN AN EXPOSED SURFACE OF VISCOUS FLUID